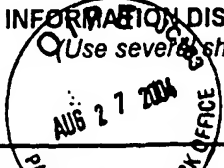


<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary) 	<b>Docket Number (Optional)</b> 16592-2	<b>Application Number</b> 10/774,839
	<b>Applicant(s)</b> Gary S. Tompa, et al.	
	<b>Filing Date</b> February 9, 2004	<b>Group Art Unit</b> 2878

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CH		2002/0174367	11/21/02	Kimmel et al.	713	201	

FOREIGN PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
CH		EP 0 542 561 A1	05/19/93	Westrom, et al.	G01T1	00		
		<del>JP 10132944</del>	<del>5/22/98</del>	<del>Jeon-Seo Park</del>	<del>G01T1</del>	<del>17</del>		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
CH		Brent R. Blaes and Martin G. Buehler, "SEU/SRAM as a Process Monitor", IEEE Transactions on Semiconductor Manufacturing, Vol. 7, No. 3, August, 1994, Pages 319-324	

Examiner Signature <b>CONSTANTINE HANNAHER</b>	Date Considered JAN 4 2006
EXAMINER: Indicate citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Form PTO-A820 (also form PTO-1449)